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January 2, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RE:

Response to Restriction Application on

Application No.: 10/602,053

Filed: June 24, 2003

IN-LINE SYSTEM AND A METHOD FOR MANUFACTURING LIQUID

CRYSTAL DISPLAY

Inventor: Dae-Ho CHOO, et al.

Our Ref: 6192.0219.C1

Sir:

The following documents are forwarded herewith for appropriate action by the U.S. Patent and Trademark Office:

- 1. a transmittal letter;
- 2. a Response to Election/Restriction Requirement; and
- 3. two (2) acknowledgement postcards.

It is respectfully requested that the attached copy of the postcard be stamped with the filing date of these documents and returned to our courier.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 23-1951 referencing docket number 6192.0219.C1.

Respectfully submitted,

Hae-Chan Park

Reg. No. 50,114

HCP/jeh **Enclosures**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re patent application of

Docket No.: 6192.0219.C1

Dae-Ho CHOO, et al.

Group Art Unit: 2879

Serial No.: 10/602,053

Examiner: RUDE, Timothy

Confirmation No.: 7598

Filed: June 24, 2003

For:

IN-LINE SYSTEM AND A METHOD FOR MANUFACTURING LIQUID

CRYSTAL DISPLAY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Sir:

In reply to the December 2, 2003 Restriction Requirement, Applicants provisionally elects Species B and sub-species I that may read on claims 56-59 and 61-69, with traverse.

It is also respectfully submitted that the subject matter of all claims is sufficiently related that a thorough search for the subject matter of any one Group of claims would encompass a search for the subject matter of the remaining claims. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it is stated that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions." It is respectfully submitted that this

Applicants: Dae-Ho CHOO, et al.

Application No.: 10/602,053

policy should apply in the present application in order to avoid unnecessary delay and expense to

Applicants and duplicative examination by the Patent Office.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

It is not believed that any extensions of time or fees are required. However, if an

extension of time is necessary to prevent abandonment of this application, then such extensions

of time are hereby petitioned under 37 C.F.R. §1.136, and any fees required therefore are hereby

authorized to be charged to our Deposit Account No. 23-1951.

Respectfully submitted,

Hae-Chan Park

Reg. No. 50,114

Dated: January 2, 2004

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